

Docket No.: 052775-0024



IFW

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	Customer Number: 20277
Masahiro NAKAYAMA, et al.	:	Confirmation Number: 1716
Application No.: 10/662,524	:	Group Art Unit: 2826
Filed: September 16, 2003	:	Examiner: not yet assigned

For: CHAMFERED FREESTANDING NITRIDE SEMICONDUCTOR WAFER AND  
METHOD OF CHAMFERING NITRIDE SEMICONDUCTOR WAFER

**STATUS INQUIRY**

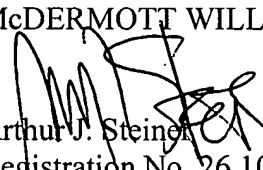
Mail Stop  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

A patent application was filed in the referenced application on September 16, 2003. Since more than twenty-one months have elapsed since that date, and no response to said patent application has been received by attorney for applicant, Applicant respectfully requests that the undersigned attorney be informed of the status of the referenced application.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

  
Arthur J. Steiner  
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**Please recognize our Customer No. 20277  
as our correspondence address.**

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**Date: June 16, 2005**